

## EAST Search History

## EAST Search History (Prior Art)

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	1	10/756,771	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/04/15 16:14
S2	458	photoelectron with plate	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/04/17 15:36
S3	106	photoelectron with plate with emitt\$3	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/04/17 15:36
S4	10	photoelectron with plate with emitt\$3 same substrate	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/04/17 15:37
S5	0	photoelectron with plate with emitt\$3 same substrate same acryl	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/04/17 15:37
S6	1	photoelectron with plate with emitt\$3 same substrate same metal	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/04/17 15:37
S7	1	photoelectron with plate with emitt\$3 same substrate same metal\$3	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/04/17 15:37

S8	7	"6,159,421"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/03 12:57
S9	17	photoelectric with plate with substrate same steel	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/03 14:32
S10	0	secondary with photoelectric same plate with substrate same steel	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/03 14:45
S11	3	second\$3 with photoelectric same plate with substrate same steel	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/03 14:45
S12	0	photoelectric same plate with substrate same steel with barrier	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/03 14:49
S13	0	photoelectric with plate same substrate same steel with barrier	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/03 14:49
S14	7	"6,159,421"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/03 15:18
S15	304	photoelectric with ceramic	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/03 16:32

S16	1	photoelectric with substrate with ceramic near layer	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/03 16:32
S17	0	photoelectric with (emission emitt\$3) with ceramic near layer	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/03 16:34
S18	20	photoelectric with (emission emitt\$3) with ceramic	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/03 16:34
S19	0	photoelectric with scintillat\$2 with ceramic	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/03 16:54
S20	10	photoelectric with scintillat\$2 with ceramic	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/03 16:55
S21	0	photoelectric with scintillat\$2 with ceramic with electrons	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/03 17:11
S22	0	photoelectric with scintillat\$2 same ceramic with electrons	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/03 17:11
S23	0	photoelectric with radiat\$3 same ceramic with electrons	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/03 17:12

S24	0	photoelectric same ceramic with emitting with electrons	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/03 17:13
S25	53	ceramic with emitting with electrons	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/03 17:13
S26	0	ultraviolet same ceramic with emitting with electrons	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/03 17:13
S27	1	ultraviolet same ceramic with emitting with electrons	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/03 17:13
S28	7	light same ceramic with emitting with electrons	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/03 17:14
S29	10	ceramic with emitting with electrons with second\$3	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/03 17:18
S30	9	("4750917"   "5380503"   "5595813"   "5616532"   "5643436"   "5650126"   "5849200"   "5853866"   "5854169").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2008/08/03 18:16
S31	4	("6159421").URPN.	USPAT	OR	OFF	2008/08/03 18:28
S32	9	("4750917"   "5380503"   "5595813"   "5616532"   "5643436"   "5650126"   "5849200"   "5853866"   "5854169").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2008/08/03 18:31

S33	371	361/213.ccls.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/03 19:21
S34	74	"5,853,866"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/04 10:48
S35	7	"6,159,421"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/04 10:53
S36	0	"Al" near "2" near "O" near "3" with conductive	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/04 11:36
S37	5527	aluminum near oxide with conductive	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/04 11:37
S38	707	aluminum near oxide with conductive with fill \$3	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/04 11:37
S39	381	aluminum near oxide with conductive with filler	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/04 11:38
S40	4	aluminum near oxide with conductive with dielectric near filler	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/04 11:38

S41	1	aluminum near oxide with conductive with resin near filler	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/04 11:41
S42	16	("2716190"   "2892139"   "2944993"   "3079289"   "3287311"   "3359521"   "3407495"   "3685026"   "3685028").PNL	US-PGPUB; USPAT; USOCR	OR	OFF	2008/08/04 11:44
S43	647	aluminum adj oxide with conductive with fill \$3	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/04 11:49
S44	4	aluminum adj oxide with conductive with dielectric near fill\$3	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/04 11:49
S45	3835	aluminum adj nitride with conductive	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/04 11:50
S46	7	aluminum adj nitride with conductive with dielectric near filler	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/04 11:50
S47	7	aluminum adj nitride with conduct\$3 with dielectric near filler	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/04 11:51
S48	5	aluminum adj nitride with conduct\$3 with resin near filler	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/04 11:52

S49	1941	aluminum adj oxide with electrical\$3 with conduct\$3	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/04 11:53
S50	1	aluminum adj oxide with electrical\$3 with conduct\$3 same dielectric near filler	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/04 11:53
S51	1	aluminum adj oxide with electrical\$3 with conduct\$3 same resin near filler	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/04 12:03
S52	7	"6,159,421"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/04 12:09
S53	3	("5137607"   "5183656"   "5244811").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2008/08/04 12:10
S54	38	("5853866").URPN.	USPAT	OR	OFF	2008/08/04 12:11
S55	1865	tin near oxide with fluorine with conduct \$3	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/04 12:26
S56	1611	tin near oxide with fluorine with conductive	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/04 12:26
S57	402	tin near oxide near fluorine with conductive	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/04 12:26

S58	11	tin near oxide near fluorine with conductivity	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/04 12:26
S59	2	"7,049,002"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/04 12:51
S60	13	photocatalytic with substrate with steel	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/04 14:07
S61	371	361/231.ccls.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/08/04 15:36
S62	0	photoelectron with plate with emitt\$3 and (Ti with Na)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 14:49
S63	89	photoelectron with plate and (Ti titanium)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 14:50
S64	12	photoelectron with plate and (Ti titanium) with (nitride carbide)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 14:51
S65	12	photoelectron with plate and ((Ti titanium) or (Zr circonium)) with (nitride carbide)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 14:52



S66	13	photoelectron with plate and ((Ti titanium) or (Zr zirconium)) with (nitride carbide)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 14:52
S67	1431	photoelectron and ((Ti titanium) or (Zr zirconium)) with (nitride carbide)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 15:26
S68	91	photoelectron same ((Ti titanium) or (Zr zirconium)) with (nitride carbide)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 15:26
S69	5	"6,620,385"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 15:36
S70	7	"6,159,421"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 15:48
S71	127086	((Ti titanium) or (Zr zirconium)) with (nitride carbide)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 16:24
S72	39595	((Ti titanium) or (Zr zirconium)) with (nitride carbide) and (ion ionizer)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 16:24
S73	39595	((Ti titanium) or (Zr zirconium)) with (nitride carbide) and (ion ionizer)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 16:25

S74	5584	((Ti titanium) or (Zr zirconium)) with (nitride carbide) same (ion ionizer)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 16:25
S75	2182	((Ti titanium) or (Zr zirconium)) with (nitride carbide) with (ion ionizer)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 16:26
S76	425	((Ti titanium) or (Zr zirconium)) with (nitride carbide) near3 (ion ionizer)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 16:26
S77	26	((Ti titanium) or (Zr zirconium)) with (nitride carbide) with (ion ionizer) same (photo photoelectric)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 16:27
S78	0	((Ti titanium) or (Zr zirconium)) with (nitride carbide) with (ion ionizer) same ( photoelectric)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 16:27
S79	19	((Ti titanium) or (Zr zirconium)) with (nitride carbide) with (ion ionizer) and ( photoelectric)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 16:28
S80	3	photoelectron with layer with thickness with roughness	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 20:30
S81	11	photoelectron with layer same thickness with roughness	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 20:33

S82	0	ionizer with layer same thickness with roughness	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 20:38
S83	2	ionizer same layer same thickness with roughness	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 20:38
S84	11	ionizer and layer same thickness with roughness	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 20:39
S85	46	ionizer and thickness with roughness	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 20:45
S86	0	ionizer and electrode with thickness with roughness	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 20:45
S87	0	ionizer and electrode with thickness with roughness	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 20:52
S88	2	ionizer and electrode with roughness	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 20:52
S89	623	electrode with thickness with roughness	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 20:54

S90	25	ioniz\$3 and electrode with thickness with roughness	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 20:55
S91	42	electrode with thickness with cover\$3 with roughness	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 21:01
S92	129	ion and thickness with cover\$3 with roughness	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 21:12
S93	10	ion same thickness with cover\$3 with roughness	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 21:12
S94	6673	(ion ionizer) same ground\$2 with electrode	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 21:16
S95	1447	(ion ionizer) same ground\$2 with emitter	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 21:16
S96	288	(ion ionizer) same ground\$2 near emitter	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 21:16
S97	190	(ion ionizer) same grounded near emitter	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 21:16

S98	1	( ionizer) same grounded near emitter	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 21:17
S99	8	( ionizer) and grounded near emitter	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 21:17
S100	1	photoelectron and ion and grounded near emitter	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 21:19
S101	567	photoelectron and ion and grounded	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 21:20
S102	147	photoelectron same ion and grounded	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 21:20
S103	147	photoelectron same ion and grounded	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 21:20
S104	14	photoelectron same ion same grounded	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 21:20
S105	5	photoelectron and cover with thickness with roughness	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/17 21:27

S106	20	"6,013,970"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/18 10:52
S107	4	"6,486,077"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/18 10:55
S108	4	"6,774,561"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/18 10:56
S109	23	"3,072,978"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/18 11:00
S110	6	"3,222,562"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/18 11:01
S111	32	"3,403,252"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/18 11:01
S112	5	"4,713,548"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/18 11:02
S113	1	10/756,771	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/18 11:46

S114	46	ionizer with mesh	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/18 11:52
S115	7	ionizer with mesh with grounded	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/18 11:53
S116	5	ionizer with mesh with grounded and flow\$3	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/18 11:53
S117	7	"6,159,421"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/02/18 13:14
S118	0	(photo adj electron photoelectron) with substrate with stainless	USPAT	OR	OFF	2009/11/30 13:06
S119	2	(photo adj electron photoelectron) same substrate with stainless	USPAT	OR	OFF	2009/11/30 13:07
S120	7	"6,159,421"	USPAT	OR	OFF	2009/11/30 13:35
S121	357	titanium near carbide with conductive	USPAT	OR	OFF	2009/11/30 14:00
S122	15	titanium near carbide near conductive	USPAT	OR	OFF	2009/11/30 14:00
S123	0	11/871,691	USPAT	OR	OFF	2009/11/30 14:29
S124	1	11/871,691	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/11/30 14:29
S125	0	"2001187390"	USPAT	OR	OFF	2009/11/30 15:50

S126	2	"2001187390"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/11/30 15:52
S127	0	photoelectron same oxygen	USPAT	OR	OFF	2009/11/30 15:53
S128	894	photoelectron same oxygen	USPAT	OR	OFF	2009/11/30 15:53
S129	429	photoelectron with oxygen	USPAT	OR	OFF	2009/11/30 15:53
S130	1	photoelectron near oxygen	USPAT	OR	OFF	2009/11/30 15:53
S131	42	photoelectron near3 oxygen	USPAT	OR	OFF	2009/11/30 15:54
S132	22	photoelectron near2 oxygen	USPAT	OR	OFF	2009/11/30 15:54
S133	0	photoelectron with oxygen near (flow stream)	USPAT	OR	OFF	2009/11/30 15:56
S134	2	photoelectron with oxygen near3 (flow stream)	USPAT	OR	OFF	2009/11/30 15:56
S135	0	10/756771	USPAT	OR	OFF	2009/11/30 15:59
S136	1	10/756,771	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2009/11/30 15:59
S137	7	"6,159,421"	USPAT	OR	OFF	2009/12/01 13:54
S138	22369	thickness with roughness	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/05/06 15:03
S139	35	thickness with roughness with underlying near layer	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/05/06 15:03
S140	5	("5602418"   "5604763"   "5742628"   "6072197"   "6232623").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2010/05/06 15:20



S141	1	("6685773").URPNL	USPAT	OR	OFF	2010/05/06 15:22
S142	401	361/213.ccls.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/08/19 14:34
S146	419	361/231.ccls.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/08/19 15:07
S147	750	361/230.ccls.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/08/19 15:46

8/19/2010 9:59:33 PM

C:\Documents and Settings\zkitov\My Documents\EAST\Workspaces\10,756,771.wsp